

## Iron Silicide-Based Ferromagnetic Metal/Semiconductor Nanostructures

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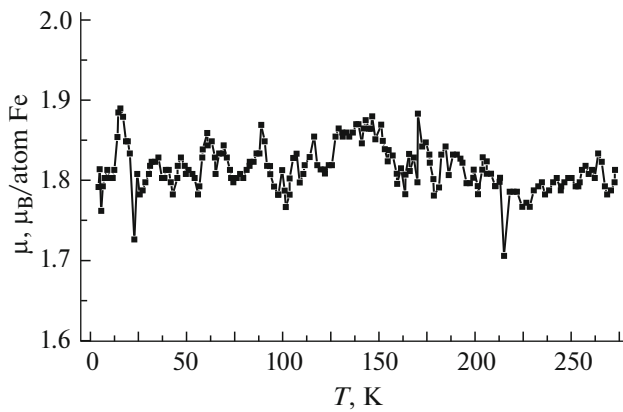
**Abstract**—Ferromagnetic single-crystal epitaxial Fe<sub>3</sub>Si films and polycrystalline Fe<sub>5</sub>Si<sub>3</sub> films are obtained on Si substrates by molecular-beam epitaxy with in situ control of the structure, optical, and magnetic properties. The results of the structural, magnetic, and optical measurements are discussed. The experimental data are compared to the results of the microscopic calculation of the spin-polarized structure, the permittivity, and the optical conductivity spectra.

DOI: 10.1134/S1063783416110299

### 1. INTRODUCTION

Nanostructures based on silicon, which is the main material of modern electronics, and ferromagnetic silicides are very interesting due to the wide spectrum of their possible applications. In the last decade, epitaxial Fe<sub>3</sub>Si films have been extensively studied to design spintronics devices [1–4]. High spin polarization of iron silicide Fe<sub>3</sub>Si also opens possibilities for designing ferromagnetic periodic structures such as magnetophoton crystals [5]. In addition, epitaxial Fe<sub>3</sub>Si films can be used in sensors of weak magnetic fields and as active materials of electrically controlled microwave devices due to their magnetoresonance properties [6]. Ferromagnetic silicide Fe<sub>5</sub>Si<sub>3</sub> with the Curie temperature near 390 K, in its turn, is very topical for applying in thermomagnetic energy converters [7]. There are also evidence that the compound manifests the giant magnetoresistance effect due to the formation of Fe<sub>5</sub>Si<sub>3</sub> nanoparticles in the silicon matrix [8]. First attempts of developing Fe/Si nanostructures have not been successful because of the formation of metal-silicide phases in the interface, which suppressed the spin-polarized transport in the semiconductor layer. Epitaxial films of various silicides such as FeSi<sub>2</sub>, FeSi with CsCl, and Fe<sub>3</sub>Si structure on Si substrates were obtained in many works [9–14]. The Mössbauer effect studies with isotopic <sup>57</sup>Fe layers were very useful for identifying various silicide phases [15]. Nevertheless,

we do not know completely silicide heterostructures; the growth of heterostructure Fe<sub>3</sub>Si/Ge/Fe<sub>3</sub>Si/Si(111) was observed in [16]. The necessity of introducing a Ge semiconductor layer instead of Si was due to lower temperature of the epitaxial growth of germanium on Fe<sub>3</sub>Si that should not be increased to avoid uncontrolled growth of silicides in the interface. Additional interest in metal silicides is due to their significant thermoelectric properties [17]. Because of this, further studies are necessary in the field of technologies of designing silicide heterostructures and searching for new silicide phases with given magnetic and transport properties. Recently we mastered the technology of preparing single-crystal layers of ferromagnetic silicide Fe<sub>3</sub>Si on Si(111) substrates by molecular-beam epitaxy [6] and also polycrystalline Fe<sub>5</sub>Si<sub>3</sub> films [18]. The equilibrium Fe<sub>5</sub>Si<sub>3</sub> phase exists only at high temperatures, at which its magnetic properties are not interesting. In this work, we present the results of the measurements of the magnetic properties and the optical spectra of Fe<sub>5</sub>Si<sub>3</sub> in comparison to the results of ab initio calculations of the electronic structure and various response functions, including the optical conductivity spectrum. We estimated the static conductivity. Knowledge of the electronic structure is necessary to understand the spin-polarized transport and also to form the thermoelectric properties.

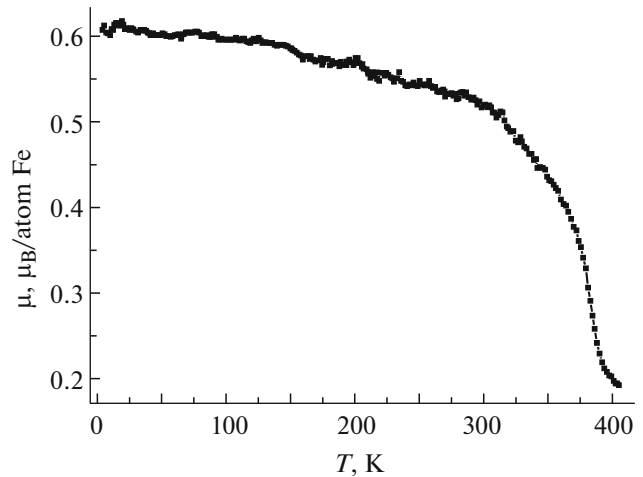


**Fig. 1.** Temperature dependence of the magnetization of  $\text{Fe}_3\text{Si}/\text{Si}$  in magnetic field  $H = 200$  Oe.

## 2. PROPERTIES OF FERROMAGNETIC $\text{Fe}_3\text{Si}$ AND $\text{Fe}_5\text{Si}_3$ FILMS

The single-crystal  $\text{Fe}_3\text{Si}$  film was prepared by simultaneous deposition of iron and silicon on the atomically pure surface of the Si(111) substrate (the resistivity was 5–10  $\Omega$  cm, the dopant was boron  $\text{B}^5$ ) under condition of ultrahigh vacuum in an “Angara” modernized unit of molecular-beam epitaxy. The base vacuum in the technological chamber was  $6.7 \times 10^{-8}$  Pa. Before synthesizing the films, the substrate was subjected to chemical treatment with subsequent thermal annealing in ultrahigh vacuum. The simultaneous sputtering of iron and silicon was performed by method of thermal evaporation from two effusion Knudsen cells made of high-temperature boron nitride. The deposition rates of individual materials were calibrated by the laser ellipsometry, which provided the ratio of the flow rates Si : Fe  $\approx 0.57$  that was stoichiometric for  $\text{Fe}_3\text{Si}$ . The process of formation of the structure was controlled in situ using a LEF-751M high-speed laser ellipsometer [6] and the method of reflected high-energy electron diffraction. According to the data of spectral ellipsometry, the integral thickness of the  $\text{Fe}_3\text{Si}$  layer was  $\sim 27$  nm.

The polycrystalline  $\text{Fe}_5\text{Si}_3$  was prepared by alternate deposition of subnanometer Fe and Si layers on the  $\text{SiO}_2/\text{Si}(100)$  surface at a substrate temperature of 330 K in ultrahigh vacuum. The alternate deposition of the Fe and Si layers was performed by thermal evaporation from the Knudsen effusion cells. The thicknesses of each of the Fe and Si layers were 0.5–0.8 nm. The summary thickness of the Fe–Si structure was about 27 nm in conversion to the density of the bulk pure materials or  $10.7 \pm 0.6$   $\mu\text{g}/\text{cm}^2$  for Fe and  $3.1 \pm 0.1$   $\mu\text{g}/\text{cm}^2$  for Si. After depositing, the sample was annealed in ultrahigh vacuum at a temperature of 720 K for 30 min [18]. The X-ray diffraction study of the sample using a D8 ADVANCE powder diffractometer ( $\text{CuK}_{\alpha 1,2}$ , Ni filter) with a VANTEC linear



**Fig. 2.** Temperature dependence of the magnetization of  $\text{Fe}_5\text{Si}_3$  in magnetic field  $H = 50$  Oe.

detector showed the existence of the  $\text{Fe}_5\text{Si}_3$  phase. It should be noted that this phase exists in the bulk material only at high temperatures and is thermodynamically unstable at room temperature.

The thermodynamic dependence of the magnetization was measured using the SQUID magnetometry in the temperature range 4–400 K. The magnetization of the  $\text{Fe}_3\text{Si}$  was almost independent of temperature in this range (Fig. 1), which agrees with the Curie temperature  $T_C = 850$  K. As is seen from Fig. 2, the Curie temperature of  $\text{Fe}_5\text{Si}_3$  is much lower ( $T_C \approx 390$  K).

In this work, the energy dependence of the optical conductivity was determined on the base of the data of multiangular spectral ellipsometry using the method described in detail in [19]. The calculations were carried out using the optical model of a uniform isotropic film with unknown thickness and permittivity on an isotropic Si substrate with known optical characteristics. The measurements were performed at  $T = 296$  K using an Ellips-1891 high-speed spectral ellipsometer.

## 3. SPECIFIC FEATURES OF THE ELECTRONIC STRUCTURE AND THE OPTICAL CONDUCTIVITY IN $\text{Fe}_3\text{Si}$ AND $\text{Fe}_5\text{Si}_3$

The electronic structure of  $\text{Fe}_3\text{Si}$  was calculated in terms of the density functional theory in a generalized gradient approximation (GGA). The spectrum of quasi-particle excitations was obtained in both the nonself-consistent  $G_0W_0$  approximation ( $G_0W_0$  is the nonself-consistent mass operator with zero Green functions and the line of interaction) and various self-consistent scGW approximations (scGW is the self-consistent mass operator with “dressed” lines) without inclusion and with inclusion of peak corrections (in the form from TDDFT (the temperature-depen-

**Table 1.** Populations of orbitals for various position and phases in  $\text{Fe}_3\text{Si}$ 

Ion	Orbital	FM		PM
		$\uparrow$	$\downarrow$	
Fe1 ( $2.5\mu_B$ )	$t_{2g}$	0.84	0.51	0.56
	$e_g$	0.92	0.18	0.69
Fe2 ( $1.5\mu_B$ )	$t_{2g}$	0.79	0.57	0.70
	$e_g$	0.77	0.38	0.53

FM and PM are ferromagnetic and paramagnetic phases, respectively.

dence density functional theory)). In all GW variants (GW is the mass operator in the Hedin's approximation), the initial iteration step was a band structure from the GGA calculation [20]. The spectral weights of electron excitations are changed most significantly in the regions of the Brillouin band in which  $d$  electrons begin to contribute to the band formation. The results of the calculations in the scGW approximation best agree with the spectra of the real and imaginary parts of the permittivity and the absorption and reflection coefficients measured on our samples [20]. The magnetic state is formed by the contributions of two structurally nonequivalent iron ions. Tables 1 and 2

**Table 2.** Populations of orbitals for various position and phases in  $\text{Fe}_5\text{Si}_3$ 

Ion	Orbital	FM		PM
		$\uparrow$	$\downarrow$	
Fe1 ( $1.9\mu_B$ )	$t_{2g}(xy)$	0.81	0.37	0.52
	$t_{2g}(xz)$	0.82	0.34	0.62
Fe2 ( $1.3\mu_B$ )	$e_g(z^2)$	0.80	0.46	0.62
	$e_g(x^2 - y^2)$	0.76	0.59	0.72
	$t_{2g}(xy)$	0.74	0.58	0.66
	$t_{2g}(xz)$	0.79	0.40	0.61
	$e_g(z^2)$	0.74	0.57	0.66
	$e_g(x^2 - y^2)$	0.73	0.57	0.65

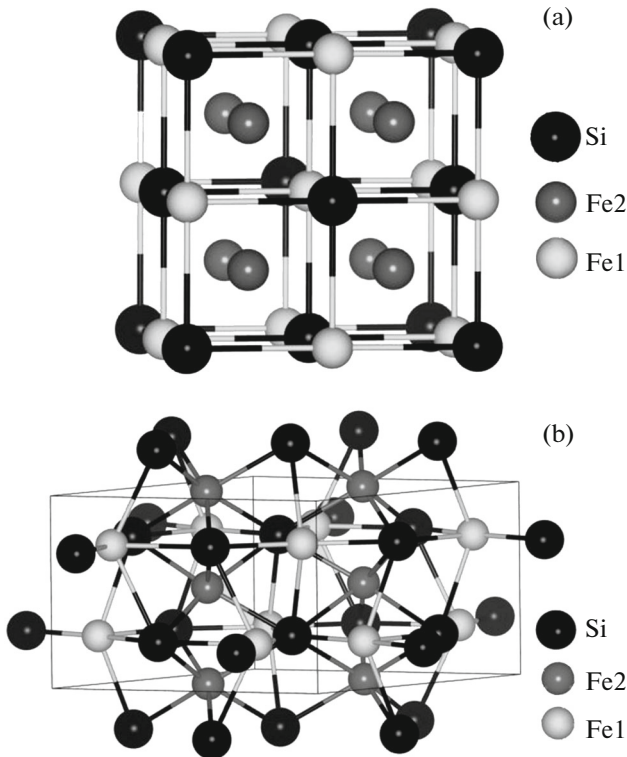
give the populations of various orbitals for each of positions.

Ions Fe1 have eight nearest neighbors Fe2 in the cubic environment and magnetic moment  $M_1 = 2.52\mu_B$  (Fig. 3). Ions Fe2 are in the tetrahedral environment of Fe1 and Si ions, and their magnetic moments is  $M_2 = 1.34\mu_B$ . Figure 4 shows the densities of states of  $\text{Fe}_3\text{Si}$  in the ferromagnetic and paramagnetic phases singly for each of the iron positions, and the same for  $\text{Fe}_5\text{Si}_3$  is shown in Fig. 5.

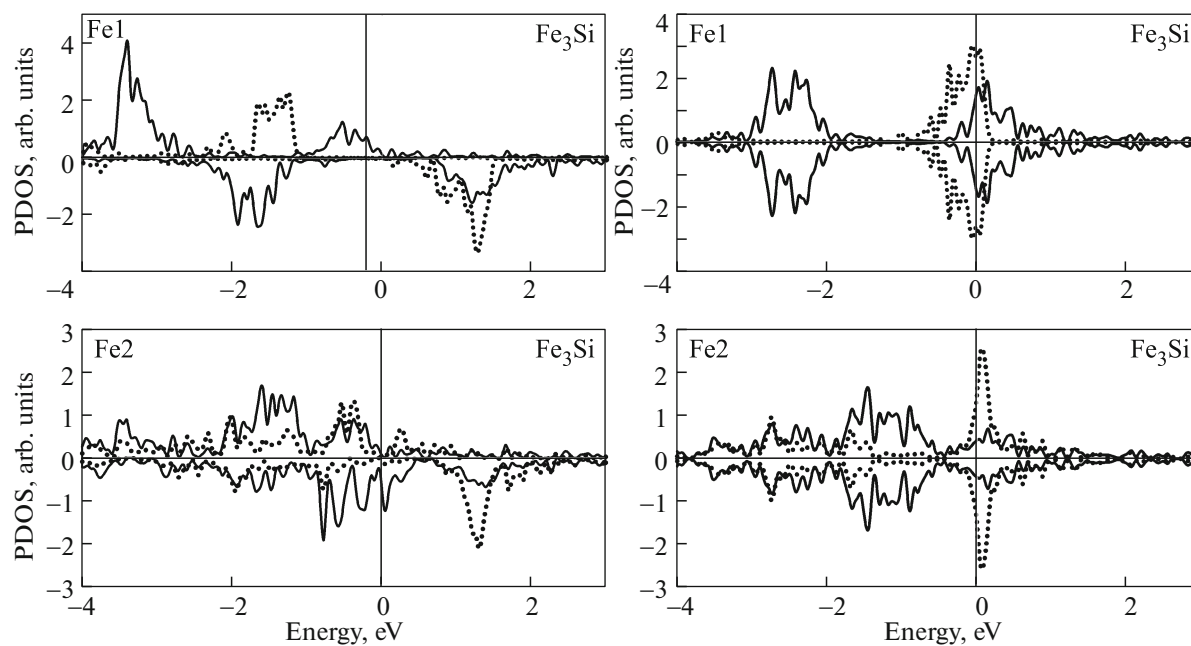
The comparison of the band structures of both silicides in the ferromagnetic and paramagnetic states showed that the transformation of the band structure at the magnetic ordering occurred more complexly than that in the simple Stoner model. At the same time, the densities of states of both silicides in the paramagnetic state had peaks at the Fermi level, which favor the fulfillment of the Stoner criterion.

#### 4. DISCUSSION OF THE RESULTS

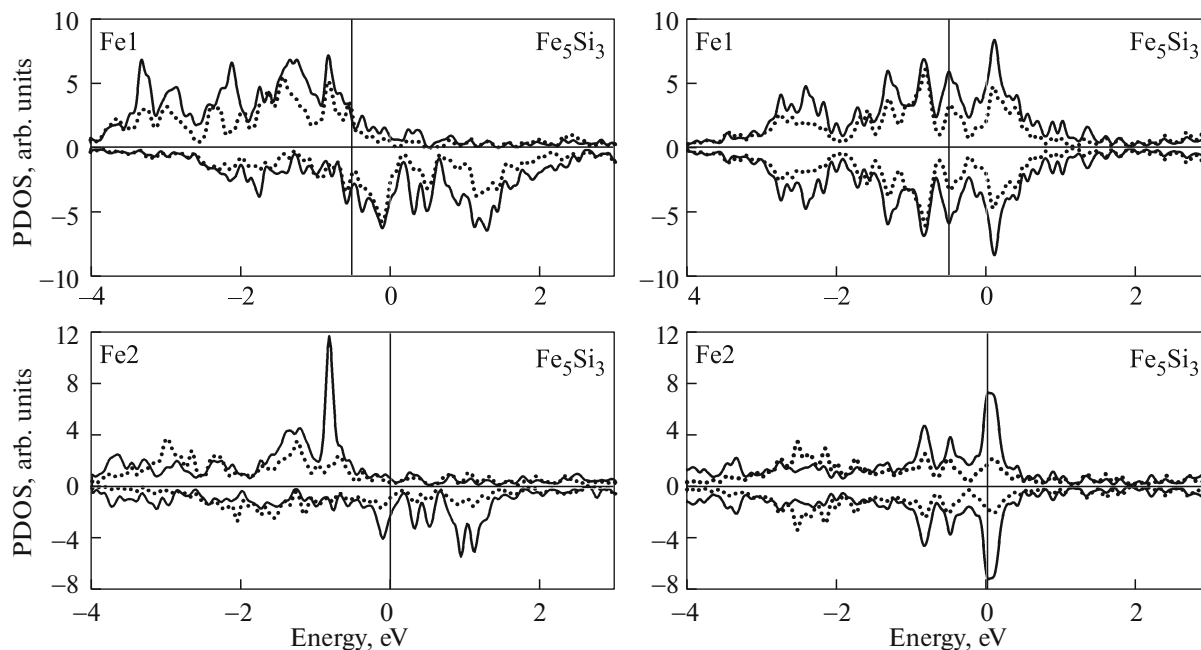
Figure 6 shows the spectra of the optical conductivity to compare the calculated and measured electronic properties of  $\text{Fe}_3\text{Si}$ . It is seen that the calculations qualitatively agree with the experiment at frequencies allowable in our measurements. In this frequency range, the interband transitions make the dominant contribution to the conductivity. With allowance for the intraband transitions, the low-frequency divergence is cut by the value of the static conductivity. In the framework of the band calculations, we can estimate the static conduction in the Drude–Lorentz model  $\sigma_0 = (\omega_p^2 \tau)/4\pi$  that uses the electronic structure parameter (plasma frequency  $\omega_p$ ) and one phenomenological parameter (relaxation time  $\tau$ ) calculated from first principles. At relaxation time  $\tau = 10$  fs typical for  $3d$  metals [21], for  $\text{Fe}_3\text{Si}$  we obtained static conductivity  $\sigma_0 = 2.5 \times 10^6$  S/m. The conductivity mea-



**Fig. 3.** Structures of (a)  $\text{Fe}_3\text{Si}$  and (b)  $\text{Fe}_5\text{Si}_3$  with two nonequivalent iron ions.



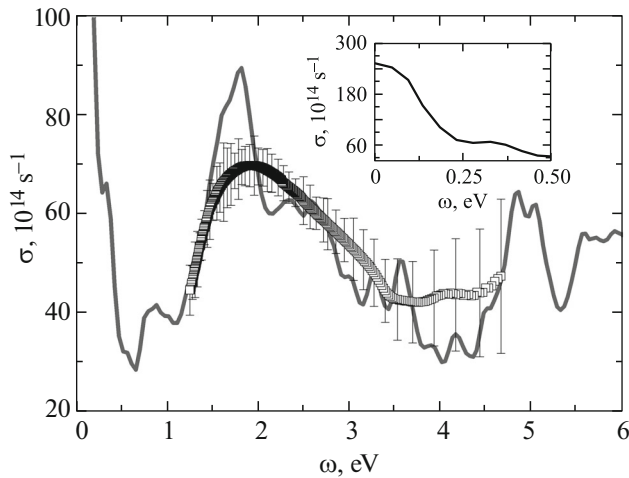
**Fig. 4.** Partial densities of states (PDOS) of  $d$  orbitals of iron in  $\text{Fe}_3\text{Si}$ . The solid line shows  $t_{2g}$  orbitals, the dotted line shows  $e_g$  orbitals, at the left in the ferromagnetic phase, and at the right in the paramagnetic phase (the GGA approximation of the density functional theory).



**Fig. 5.** Partial densities of states (PDOS) of  $d$  orbitals of iron in  $\text{Fe}_5\text{Si}_3$ . The solid line shows  $t_{2g}$  orbitals, the dotted line shows  $e_g$  orbitals, at the left in the ferromagnetic phase, at the right in the paramagnetic phase (the GGA approximation of the density functional theory).

sured on our samples at a temperature of 6.7 K was  $\sigma_0 = 1.82 \times 10^6$  S/m. A comparison with the conductivity of pure iron  $10^7$  S/m shows that silicide  $\text{Fe}_3\text{Si}$ ,

while it is a metallic compound, has a lower conductivity than that of pure metals. The much lower Curie temperature (390 K) of the  $\text{Fe}_5\text{Si}_3$  phase can provide



**Fig. 6.** Optical conductivity of  $\text{Fe}_3\text{Si}$ : (solid line) the theoretical calculation in the framework of the self-consistent scGW method and (symbols) the experimental results. The insert shows the calculated low-frequency conductivity.

larger spin fluctuations and their influence on the conductivity and the thermoelectric properties in the temperature range  $T \sim 300\text{--}500$  K as compared to those of  $\text{Fe}_3\text{Si}$ .

According to the Ioffe formula for the thermoelectric quality factor, a high-quality thermoelectric material can simultaneously have high electrical conductivity, high thermopower, and low thermal conductivity. Metals have high electrical conductivity but high thermal conductivity and low thermopower. The influence of the spatial inhomogeneity in nanostructures under study provides hope on a decrease in the thermal conductivity. The thermoelectric properties of the designed nanostructures are the subject of experimental studies at the present time.

#### ACKNOWLEDGMENTS

The authors are very grateful to I.S. Sandalov for the useful discussion and the assistance in the interpretation of the obtained results.

This work was supported by the Russian Science Foundation, project no. 16-13-00060.

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*Translated by Yu. Ryzhkov*